



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2815  
Examiner: Edgardo Ortiz  
Confirmation No.: 6303

In re PATENT APPLICATION of:

Applicant: Akira TAKAHASHI  
Serial No.: 10/798,482  
Filed: March 12, 2004  
For: Dry etching method for semiconductor device  
Docket No.: OKI 414

**SUBMISSION OF  
FORMAL DRAWINGS**

July 12, 2005

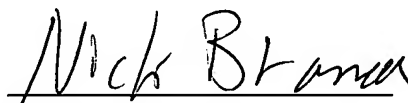
**MAIL STOP AMENDMENT – no fee**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant hereby submits 3 sheets of replacement Formal Drawings (Figs. 1-3(c)).

Respectfully submitted,



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July 12, 2005  
Date

NSB:klc